



ATION DISCLOSURE CITATION IN AN APPLICATION

JAN 24 2005

(Use several sheets if necessary)

Docket Number (Optional) 81788.0267	Application Number 10/795,839
Applicant NITTA, et al.	
Filing Date March 8, 2004	Group Art Unit 2814

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
WSL	2001-015794	01/19/01	JAPAN			Abstract	
↓	2000-208818	07/28/00	JAPAN			Abstract	
✓	2001-059922	03/06/01	JAPAN			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER  DATE CONSIDERED 8/30/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

FORM PTO-1449	Docket Number (Optional) 81788.0267	Application Number 10/795,839
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		
JAN 3 1 2005 (Use several sheets if necessary)	Applicant Koichi Nitte, et al.	
	Filing Date March 8, 2004	Group Art Unit: 2814

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
WSL	10-261821	09-29-1998	Japan			Abstract Only	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Office Action dated December 20, 2004 from Korean Patent Office (10-2004-0077336) for the foreign counterpart of U.S. patent application No. 10/795,839

EXAMINER 	DATE CONSIDERED <u>3/30/05</u>
--	--------------------------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.